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APPLICATION NO. FILING DATE FIRST NAMED INVENTOR ATTORNEY DOCKET NO. CONFIRMATION NO. 10/737,370 12/16/2003 Jean-Hua Yuen N1085-00250 5375 [TSMC2003-082 8933 7590 01/24/2005 **EXAMINER** DUANE MORRIS, LLP DOUGHERTY, ANTHONY T IP DEPARTMENT ART UNIT PAPER NUMBER ONE LIBERTY PLACE PHILADELPHIA, PA 19103-7396 2863

DATE MAILED: 01/24/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

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iner. 5(a). 37 CFR 1.121(d). rm PTO-152.	
· tional Stage	

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		Application No.	Applicant(s)		
	Office Action Comments	10/737,370	YUEN ET AL.		
	Office Action Summary	Examiner	Art Unit		
		Anthony T. Dougherty	2863		
Period fo	The MAILING DATE of this communication app or Reply	ears on the cover sheet with the c	orrespondence address -		
THE - Exte after - If the - If NC - Failt Any	MAILING DATE OF THIS COMMUNICATION. Insions of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. In period for reply specified above is less than thirty (30) days, a reply poperiod for reply is specified above, the maximum statutory period we use to reply within the set or extended period for reply will, by statute, reply received by the Office later than three months after the mailing led patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be ting within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communica D (35 U.S.C. § 133).	ation.	
Status					
1)🖂	Responsive to communication(s) filed on 17 No.	ovember 2004.			
		action is non-final.			
3)□	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.				
Disposit	ion of Claims				
5)⊠ 6)⊠ 7)⊠	Claim(s) <u>1-20</u> is/are pending in the application. 4a) Of the above claim(s) is/are withdraw Claim(s) <u>15-20</u> is/are allowed. Claim(s) <u>1-5 and 7-11</u> is/are rejected. Claim(s) <u>6 and 12-14</u> is/are objected to. Claim(s) are subject to restriction and/or	vn from consideration.			
Applicat	ion Papers				
10)⊠	The specification is objected to by the Examine The drawing(s) filed on <u>17 May 2004</u> is/are: a). Applicant may not request that any objection to the Replacement drawing sheet(s) including the correction The oath or declaration is objected to by the Examine	☑ accepted or b)☐ objected to be drawing(s) be held in abeyance. See ion is required if the drawing(s) is obj	e 37 CFR 1.85(a). jected to. See 37 CFR 1.12		
Priority (under 35 U.S.C. § 119				
a)	Acknowledgment is made of a claim for foreign All b) Some * c) None of: 1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the priorical application from the International Bureause the attached detailed Office action for a list	s have been received. s have been received in Applicati rity documents have been receive u (PCT Rule 17.2(a)).	ion No ed in this National Stage		
Attachmen	nt(s)				
	ce of References Cited (PTO-892)	4) 🔲 Interview Summary	(PTO-413)		
2) Notice 3) Infor	ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) er No(s)/Mail Date	Paper No(s)/Mail Da	ate Patent Application (PTO-152)		

DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1-5 and 7-11 rejected under 35 U.S.C. 103(a) as being unpatentable over U.S. Patent No. 4,752,898 to Koenig in view of U.S. Patent No. 4,529,932 To Doueihi et al.

With regard to claims 1 and 7 the primary reference to Koenig discloses apparatus for detecting wafer flat shift (see abstract), with a plurality of sensors in a power supply circuit for shutting off wafer fabrication equipment (see column 3 line 18-40), with optical beam sensors (see column 3 line 36-60), the sensor detecting a shift in wafer flat position (see column 3 line 61-64), and the power supply circuit shutting off the wafer fabrication equipment when the shift exceeds a set amount (see column 3 line 18-31). However, Koenig fails to discloses a relay circuit for operating a solenoid.

The secondary reference to Doueihi discloses a relay circuit for operating a solenoid (see column 3 line 23-32).

It would have been obvious to one of ordinary skill in the art at the time the invention was made to have specified the physical actuating means to shut off a power supply of Koenig be a relay operating a solenoid.

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Accordingly, such a modification would have been obvious since Doueihi et al. teaches a sufficient actuating mechanism for shutting down a source of power is a relay operating a solenoid (even though this is physically shutting down fuel supply as opposed to disconnecting electrical contacts the difference in use of a solenoid controlled by a relay is readily apparent and obvious to anyone of ordinary skill in circuits and the electronic design art) (see Doueihi et al. column 3 line 23-32), thereby suggesting the obviousness of the modification.

With regard to claims 2 and 8, and applying the rejection of claims 1 and 7 above, the primary reference to Koenig discloses the sensors adjusted to detect a wafer flat shift in a plurality of directions of angular displacement (see column 3 line 64 through column 4 line 34).

With regard to claims 3 and 10, and applying the rejection of claims 1 and 7 above, the primary reference to Koenig discloses the sensors adjusted to detect a wafer flat shift in a range of $(2)(0.9^{\circ})$ to $(5)(0.9^{\circ})$ angular displacement (see column 4 line 23-32).

With regard to claim 4, and applying the rejection of claim 1 above, the primary reference to Koenig discloses a frame (see Figure 1), and an adjustable mounting mechanism mounting each sensor on the frame for adjustment along orthogonal axes (see column 3 line 36-60).

With regard to claim 5, and applying the rejection of claim 1 above, the primary reference to Koenig discloses a frame (see Figure 1), and sensors being adjustably mounted on the frame (see column 3 line 36-60).

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With regard to claim 9, and applying the rejection of claim 7 above, the primary reference to Koenig discloses detecting the wafer flat shift by optical beam sensors (see column 3 line 36-60).

With regard to claim 11, and applying the rejection of claim 7 above, the primary reference to Koenig discloses detecting the wafer flat shift by optical beam sensors and adjusting the position of the sensors (see column 3 line 36-60).

Allowable Subject Matter

- 3. Claims 15-20 allowed.
- 4. Claims 6, and 12-14 objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 5. The following is a statement of reasons for the indication of allowable subject matter:

The primary reason for the allowance of claims 6, 12-14, and 15-20 is the inclusion of the limitations of an apparatus for detecting a wafer flat shift which includes a relay activated by signals from sensors detecting an angular displacement of a wafer flat, a solenoid operated by the relay to open a door to release a corresponding wafer for further fabrication, and when a wafer

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flat shift is sensed shut off the sensors which activate the door. It is these limitations found in each of the claims, as they are claimed in the combination, that has not been found, taught or suggested by the prior art of record which makes these claims allowable over the prior art.

Conclusion

6. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, THIS ACTION IS MADE FINAL. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Anthony T. Dougherty whose telephone number is (571) 272-2273. The examiner can normally be reached on Monday through Friday from 8 to 5.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John E. Barlow can be reached on (571) 272-2269. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

atd

Supervisory Patent Examiner Technology Center 2800